

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Ki-yeon Park; Sung-tae Kim; Young-sun Kim; In-sung Park; Jae-hyun Yeo;  
Yun-jung Lee; Ki-vin Im  
Application No.: To Be Assigned  
Filed: Concurrently Herewith  
For: METHODS OF FORMING METAL THIN FILMS, LANTHANUM OXIDE FILMS,  
AND HIGH DIELECTRIC FILMS FOR SEMICONDUCTOR DEVICES USING  
ATOMIC LAYER DEPOSITION

April 21, 2004

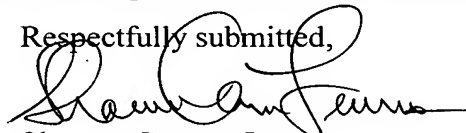
Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)**

Sir:

Attached is a list of documents on form PTO-1449 together with a copy of each identified document. It is requested that these documents be considered by the Examiner and officially made of record in accordance with the provisions of 37 C.F.R. § 1.56 and Section 609 of the MPEP. No fee is believed due. However, the Commissioner is hereby authorized to charge any deficiency or credit any overpayment to Deposit Account No. 50-0220.

Respectfully submitted,

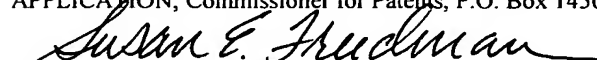
  
Shawna Cannon Lemon  
Registration No. 53,888

Myers Bigel Sibley & Sajovec, P.A.  
P. O. Box 37428  
Raleigh, North Carolina 27627  
Telephone: (919) 854-1400  
Facsimile: (919) 854-1401  
Customer No. 20792

**CERTIFICATE OF EXPRESS MAILING**

Express Mail Label No. EV 381442928 US  
Date of Deposit: April 21, 2004

I hereby certify that this correspondence is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR § 1.10 on the date indicated above and is addressed to: Mail Stop PATENT APPLICATION, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

  
Susan E. Freedman

Date of Signature: April 21, 2004

